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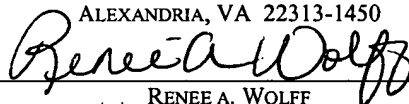
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Oikari et al.	Examiner: Carillo, Bibi Sharidan
Serial No.: 10/613,931	Group Art Unit: 1746
Filed: July 3, 2003	Docket No.: FSI0111/US
For: WAFER PROCESSING USING GASEOUS ANTISTATIC AGENT DURING DRYING PHASE TO CONTROL CHARGE BUILD- UP	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I CERTIFY THAT ON 12 August 2005, THIS PAPER
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AMENDMENT, COMMISSIONER FOR PATENTS, P.O. BOX 1450,
ALEXANDRIA, VA 22313-1450


RENEE A. WOLFF

INFORMATION DISCLOSURE STATEMENT

The documents listed on the enclosed Form PTO-1449 are presented pursuant to Applicant's duty of disclosure under 37 C.F.R. 1.56. In accordance with 37 C.F.R. 1.98(a)(2), enclosed is a copy of each of the foreign patents and non-patent publications. The Examiner is requested to indicate consideration of each reference by initialing in the appropriate box for each reference, and returning an initialed copy with the next Official Action.

No fee is believed to be necessary for the consideration of this Information Disclosure Statement since it is being filed before the receipt of an Office Action on the merits. In case the papers cross in the mail, it is requested that consideration of this Information Disclosure Statement be given under 37 C.F.R. § 1.97 (c)(2). If any fee is required, please charge our Deposit Account No. 50-1775 and notify us of the same.

Respectfully Submitted,

Dated: 12 AUG 05By: 

Kevin J. Hubbard, Reg. No. 50,717

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